

CUSTOMER NO.: 27623

FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Docket Number (Optional) 2133.062USU	Application Number 107511557 Not Yet Assigned
	Applicant Mund and Leib	
	Filing Date Herewith	Group Art Unit Not Yet Assigned

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
/MW/	0 280 905 A2	9/7/88	Europe			X	
/MW/	DE10222609.1A1	5/23/02	Germany				X
/MW/	DE10222958.9A1	5/23/02	Germany				X
/MW/	DE10222964.3A1	5/23/02	Germany				X
/MW/	DE10252787.3A1	11/13/02	Germany				X
/MW/	DE10301559.0A1	10/30/03	Germany				X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

/MW/	XP-10232226A-1, Anodic Bonding Technique Under Low-Temperature and Low-Voltage Using Evaporated Glass, Woo-Beom Choi et al., 9 th Int'l Vacuum Microelectronics Conference, St. Petersburg 1996, pgs 427-430
EXAMINER	/Mary Wilczewski/
DATE CONSIDERED	05/03/2007
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	

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